

From narrow gap to ultra-wide band gap systems: End of band gap problem excuses for defect calculations

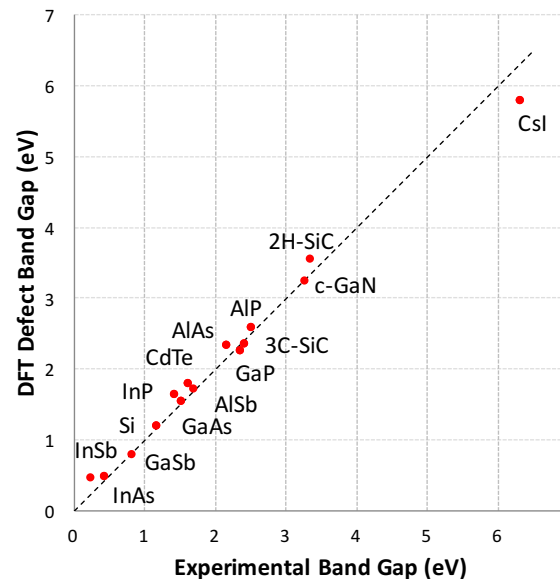
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Why model defects in semiconductors and insulators?

Radiation effects in electronics

Process modeling for semiconductors

Defect chemistry for energy applications

Goals:

(1) Qualitative understanding - *Forensics*

Augment experiments

- incomplete, inconclusive, unavailable, expensive

(2) Quantitative characterization - *Predictive*

Predictive simulations, inform coarser models

- not just publishable, but defensible to engineers

The DFT defect shibboleths

- **“If you do not have the right band gap, you cannot hope to get the defect levels right”**
- **If you have the right band gap, you will get accurate defect levels**

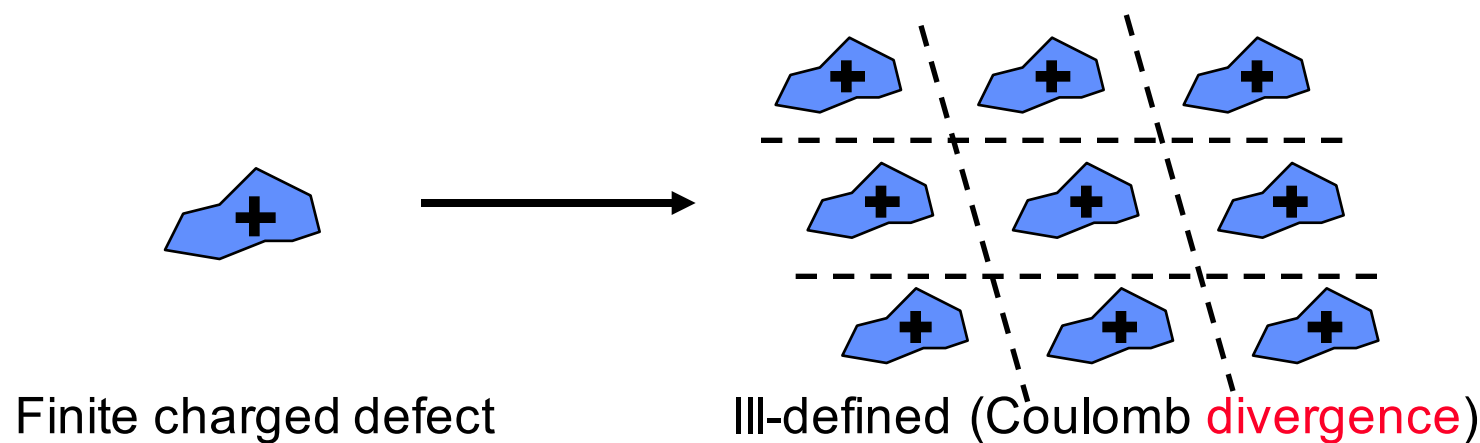
By the end of this talk ...

- the Kohn-Sham gap mostly irrelevant to defect levels
- boundary-conditions/finite-size-errors matter more
- accuracy *proven* with standard semi-local functionals

Challenges for density functional theory

- **Conventional DFT fails for defect levels in semiconductors**

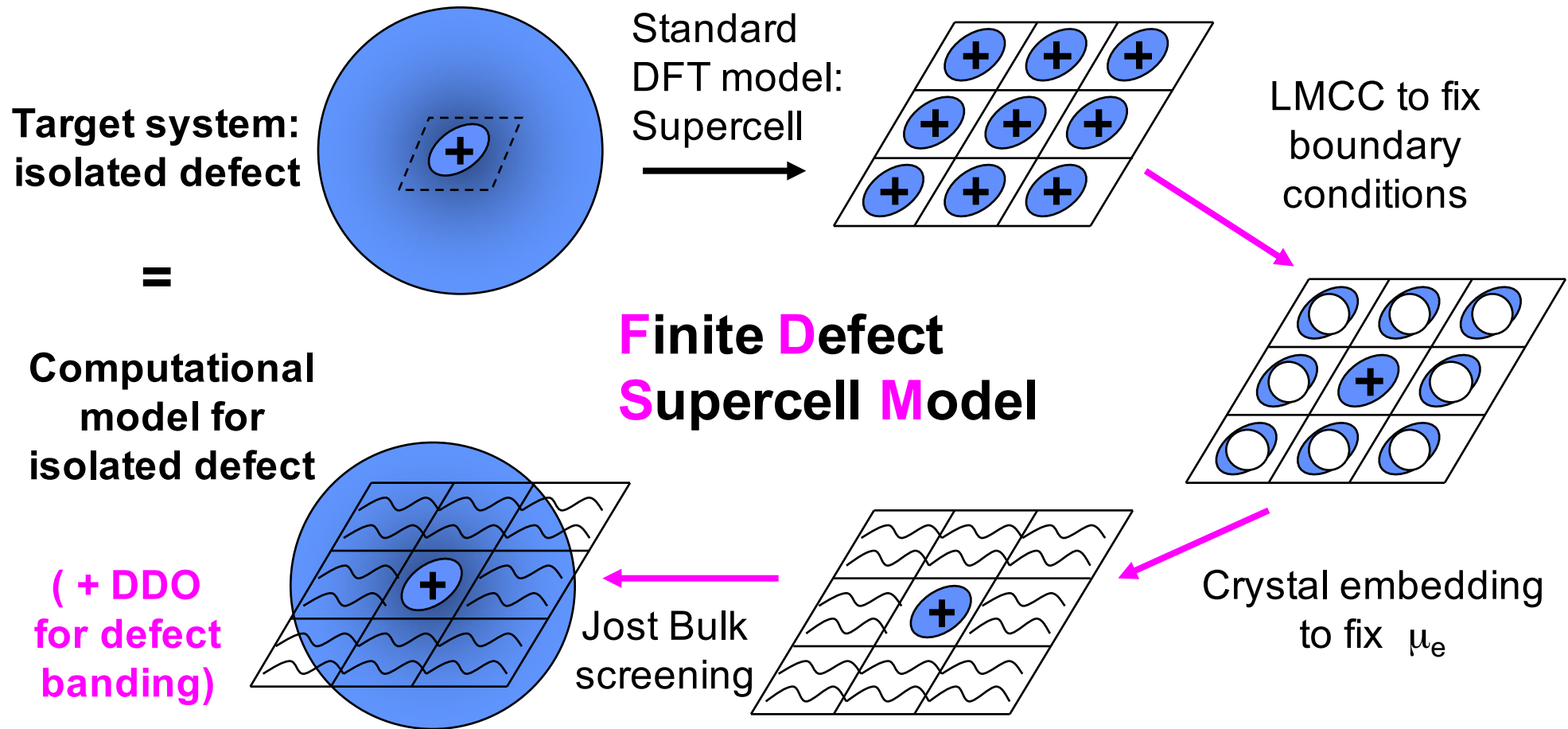
- (1) Physical accuracy: e.g., “band gap problem”
- (2) Computational model size limitations
- (3) Shortage of good data for validation
- (4) Supercell problem for charged defects:



Lots of DFT calculations, no robust, predictive method

A supercell theory of defect energies

Peter A. Schultz, Phys. Rev. Lett. **96**, 246401 (2006).



"Ab initio" computational model – connect model to physics
Calculations with rigorous control of charge boundary conditions

(i.e., not jellium-based)

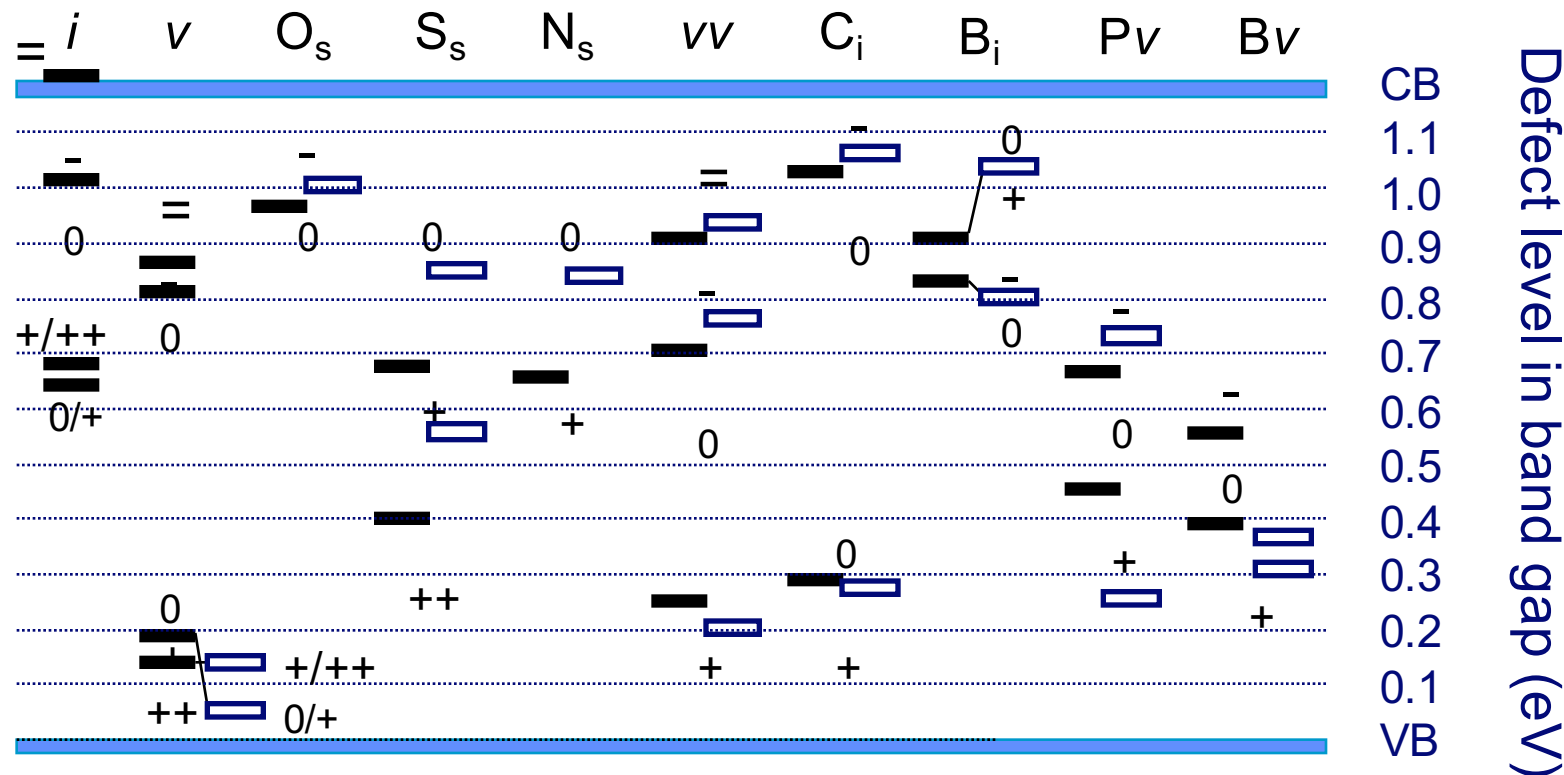
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Defect level in band gap (eV)

LDA Kohn-Sham gap is only 0.5 eV

Si: DFT/PBE vs. Experimental Levels

P.A. Schultz and A.H. Edwards, NIMB **327**, 2-8 (2014).



... and several other defects

DFT/PBE defect level max |error|=0.20 eV, mean |error|=0.10 eV
DFT “defect gap” matches experiment (KS gap: 0.6 eV)

Absence of validated HSE/hybrid functional results

Computational methods – III-V's

- **General purpose DFT code SeqQuest** (<http://dft.sandia.gov/Quest>)
 - well-converged (contracted-Gaussian) local orbital basis
 - both LDA and PBE functionals
 - converged norm-conserving pseudopotentials (Ga, In both $Z_{\text{val}}=3,13$)
 - full force relaxed (<1 meV total energies)
 - **full FDSM ... robust control of boundary conditions**
- **Large bulk simulation supercells**
 - $a_0=a_0(\text{theory})$; GaAs: 5.60Å(LDA), 5.63Å(3d), 5.74Å(PBE); $a_0(\text{expt})=5.65$ Å
 - Up to 1000-atom supercells; cubic: 64-, 216-, 512-, 1000-site
 - **k -sampling**: 3^3 for 64-site cells, 2^3 for larger (up to 1000-site) supercells,
 - explicit bulk screening
 - **all these computational parameters are *tested* for convergence**

Comparable to methods that yielded 0.1 eV accuracy in Si

Simple intrinsic defects in GaAs: LDA

P.A. Schultz and O.A. von Lilienfeld, MSMSE 17, 084007 (Dec. 2009).

216- = 512- = 1000-site

Verification: cell-converged

LDA-3d = LDA to ≤ 0.1 eV

Verification: PP converged

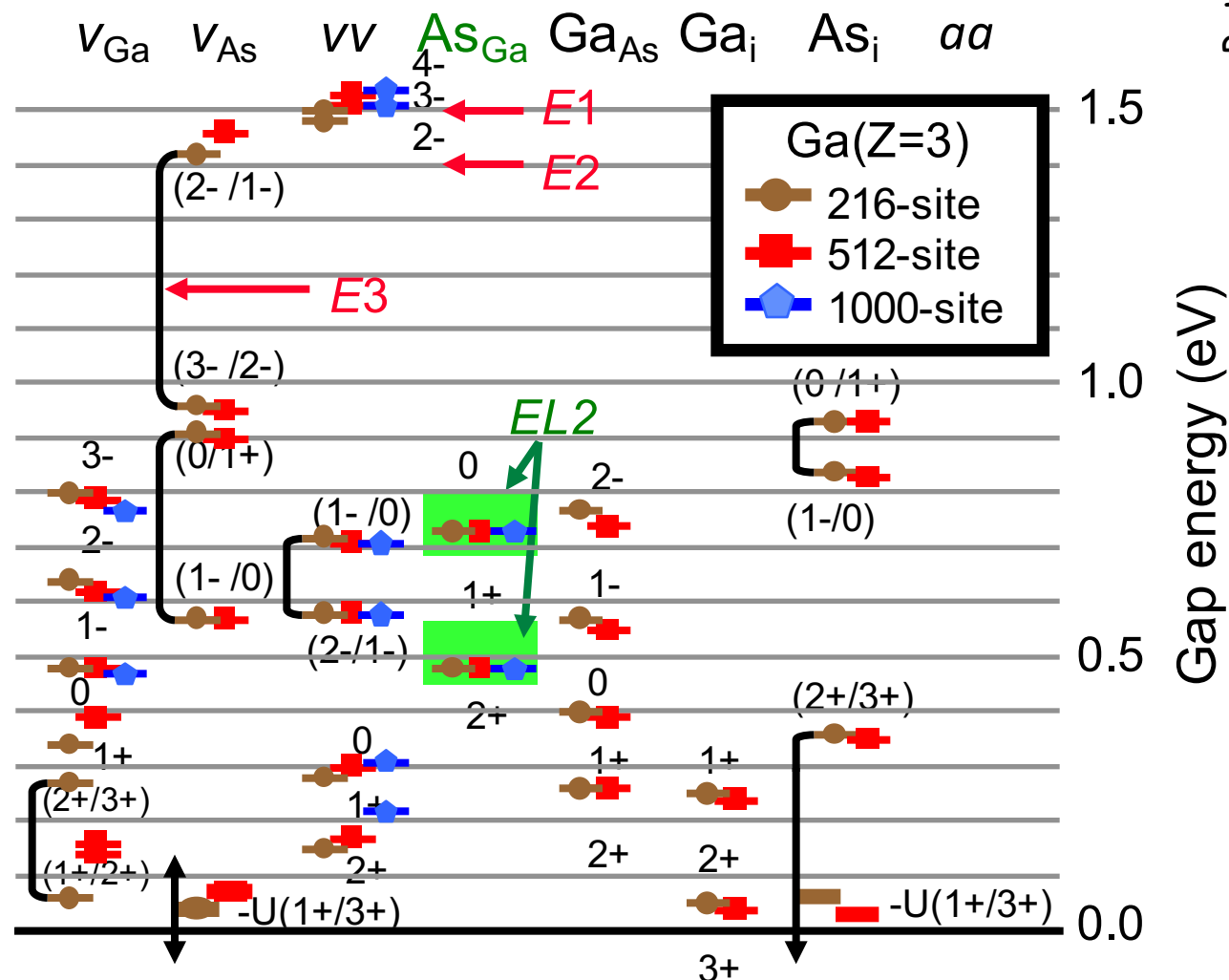
LDA~PBE; spin < 0.05 eV

Verification: functionals

As_{Ga} levels = *EL2* levels

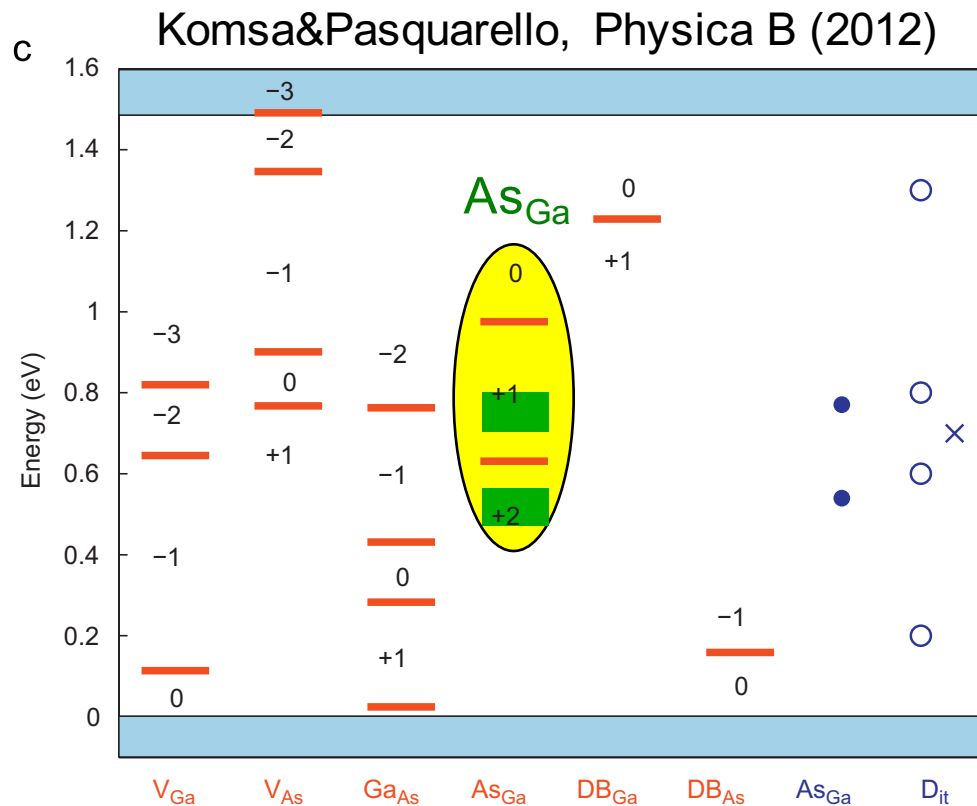
V_{Ga} levels below midgap

Validation: levels < 0.1 eV



DFT+FDSM: Apparent accuracy of ~ 0.1 eV

HSE for GaAs defects?



HSE gives **worse** results for EL2/ As_{Ga}

(but: huge HSE computational cost ... small cell, large-core PP)

E1-E2 radiation center is the GaAs divacancy

P.A. Schultz, J. Phys.: Condens. Matter **27**, 075801 (2015).

Old (experimental) lore, back to 1988:

$E1, E2$ center = $v_{As}(-/0), v_{As}(0/+)$

$E3 = v_{As} + i$

vv is dismissed

Level structure reassigned with DFT:

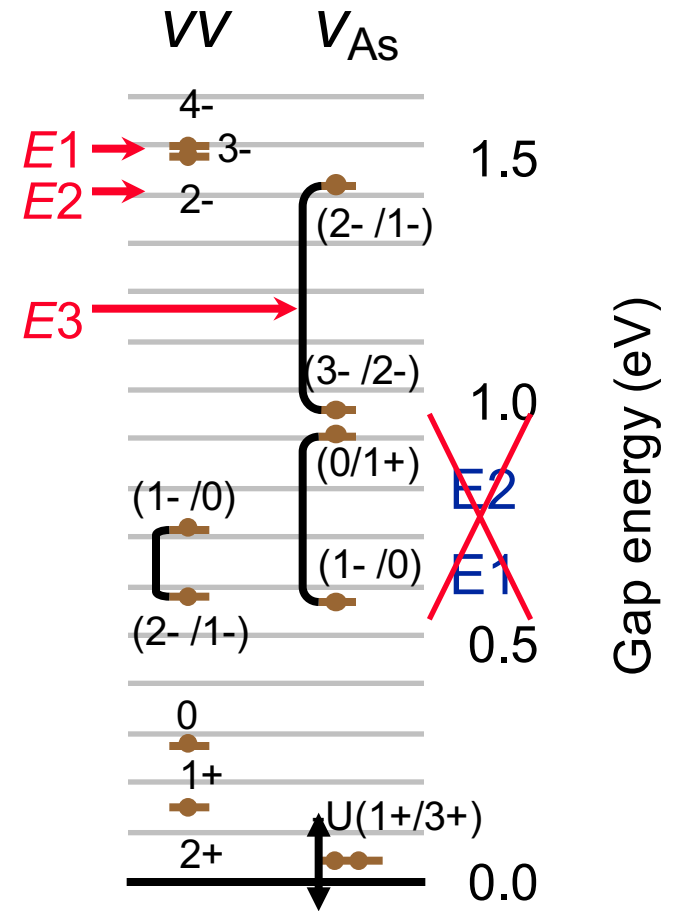
$v_{As}(-/+)$ is mid-gap negative-U (only *one* level)

$v_{As}(3-/1-)$ is upper-gap -U (*one* level)

$vv(4-/3-/2-)$ near conduction band

vv is major radiation defect: $E1-E2$

$v_{As}(3-/1-)$ transition is the $E3$

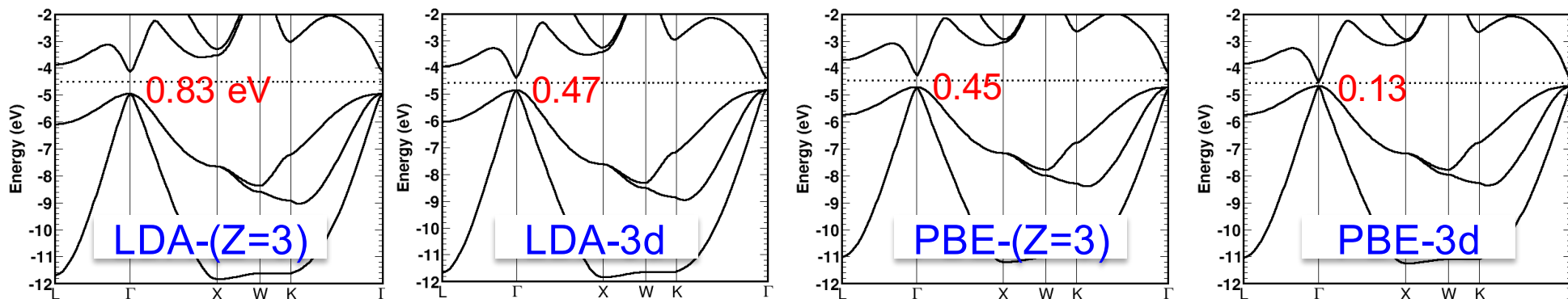


DFT-SeqQuest+FDSM levels good enough to identify defects based on **quantitative** defect level calculations

GaAs: A theoretical band gap laboratory

P.A. Schultz and A.H. Edwards, NIMB **327**, 2-8 (2014).

Change the Ga pseudopotential and the functional, and the **KS band gap** shrinks...



from 0.83 eV, LDA, Ga(Z=3) pseudopotential (PP) ...

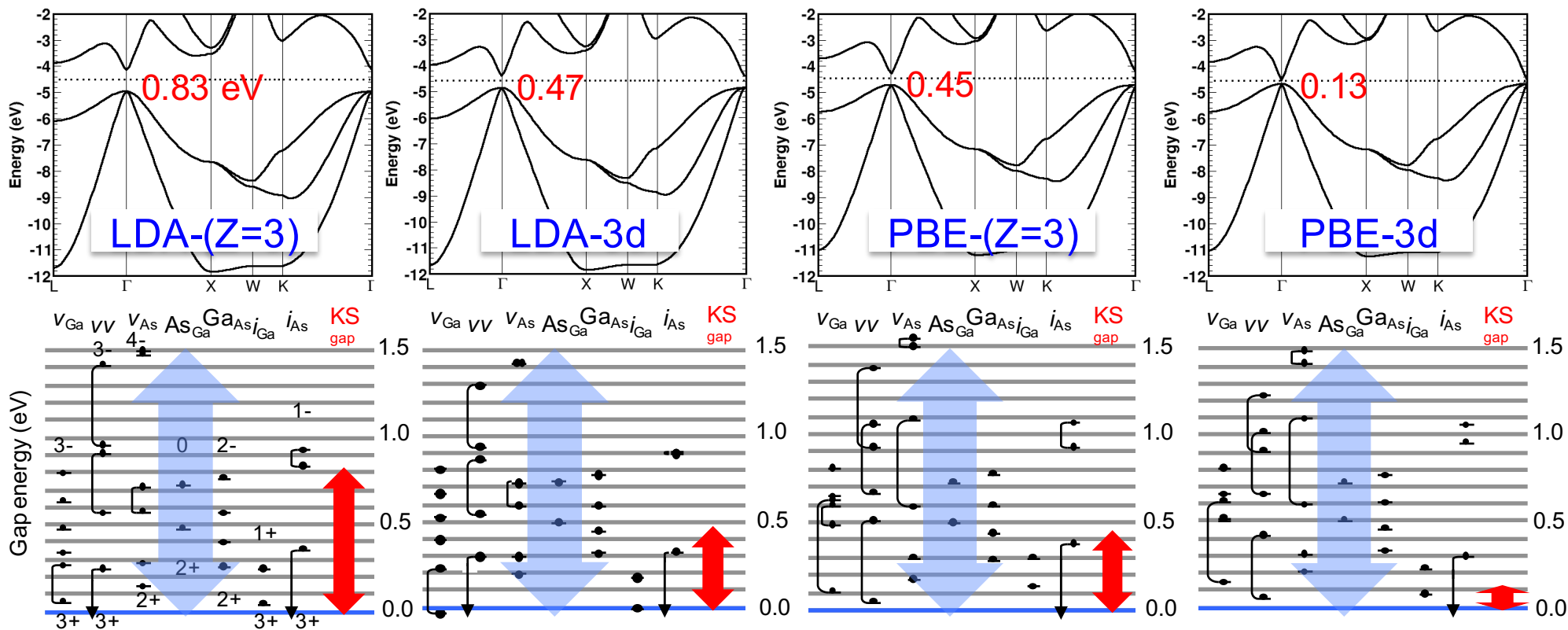
... to 0.13 eV, PBE-3d, Ga(Z=13) pseudopotential (PP)

GaAs: A theoretical laboratory

P.A. Schultz and A.H. Edwards, NIMB **327**, 2-8 (2014).

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Change the Ga pseudopotential and the functional, and the **KS band gap** changes ...



... but span of (total-energy-based) defect levels, the “defect band gap”, does not

Defect levels/gap ***insensitive*** to size of Kohn-Sham gap!

The DFT “Defect band gap”

- Kohn-Sham gap: **outside** bounds of VB to CB *band eigenvalues*
- **Defect band gap**: **inside** bounds of transition *energies* for defect levels

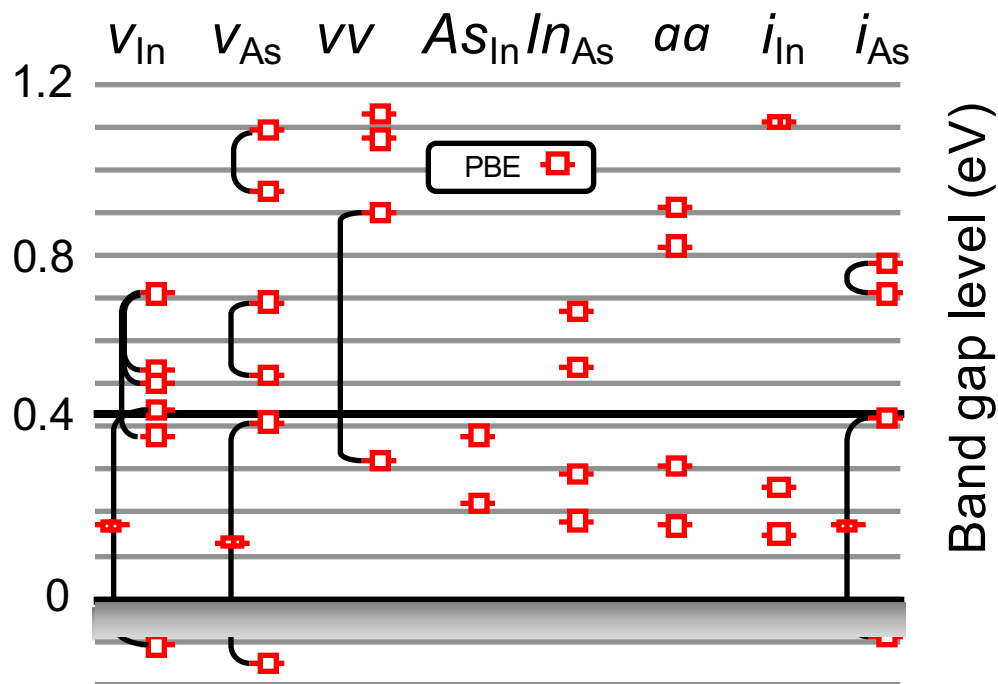
Band gaps: **experiment**, Kohn-Sham, **DFT defect gap**

Si			AlAs			AlP		
1.17 eV			2.16 ⁱ eV			2.51 eV		
	KS	Defect		KS	Defect		KS	Defect
lda	0.49	1.2	lda	1.37	2.3	lda	1.48	2.55
pbe	0.62	1.2	pbe	1.53	2.3	pbe	1.67	2.55
GaAs			GaP			InP		
1.52 eV			2.35 ⁱ eV			1.42 eV		
	KS	Defect		KS	Defect		KS	Defect
lda	0.83	1.54	lda	1.51	2.35	lda	0.67	1.7
lda-3d	0.47	1.52	lda-3d	1.47	2.35	lda-3d	0.66	1.7
pbe	0.45	1.50	pbe	1.74	2.35	pbe	0.47	1.7
pbe-3d	0.13	1.50	pbe-3d	1.52	n/c	pbe-3d	0.46	n/c

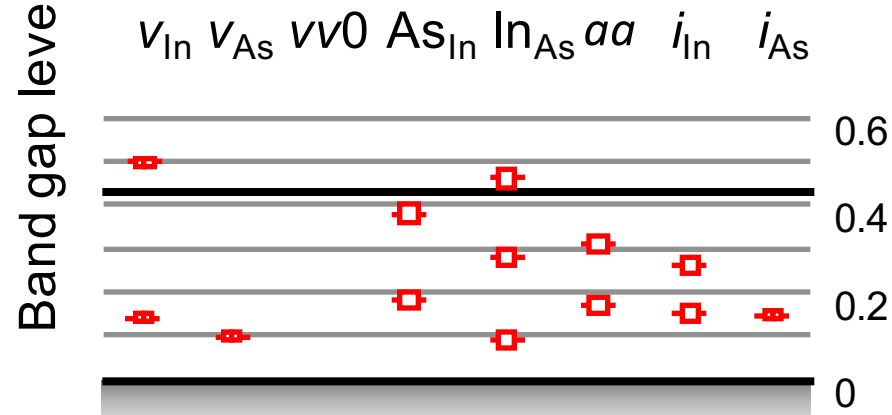
Defect band gap matches (overshoots?) experiment

InAs – no KS-DFT gap, no defects?

“Small” cell (216-site)



Asymptotic local (1000-site)



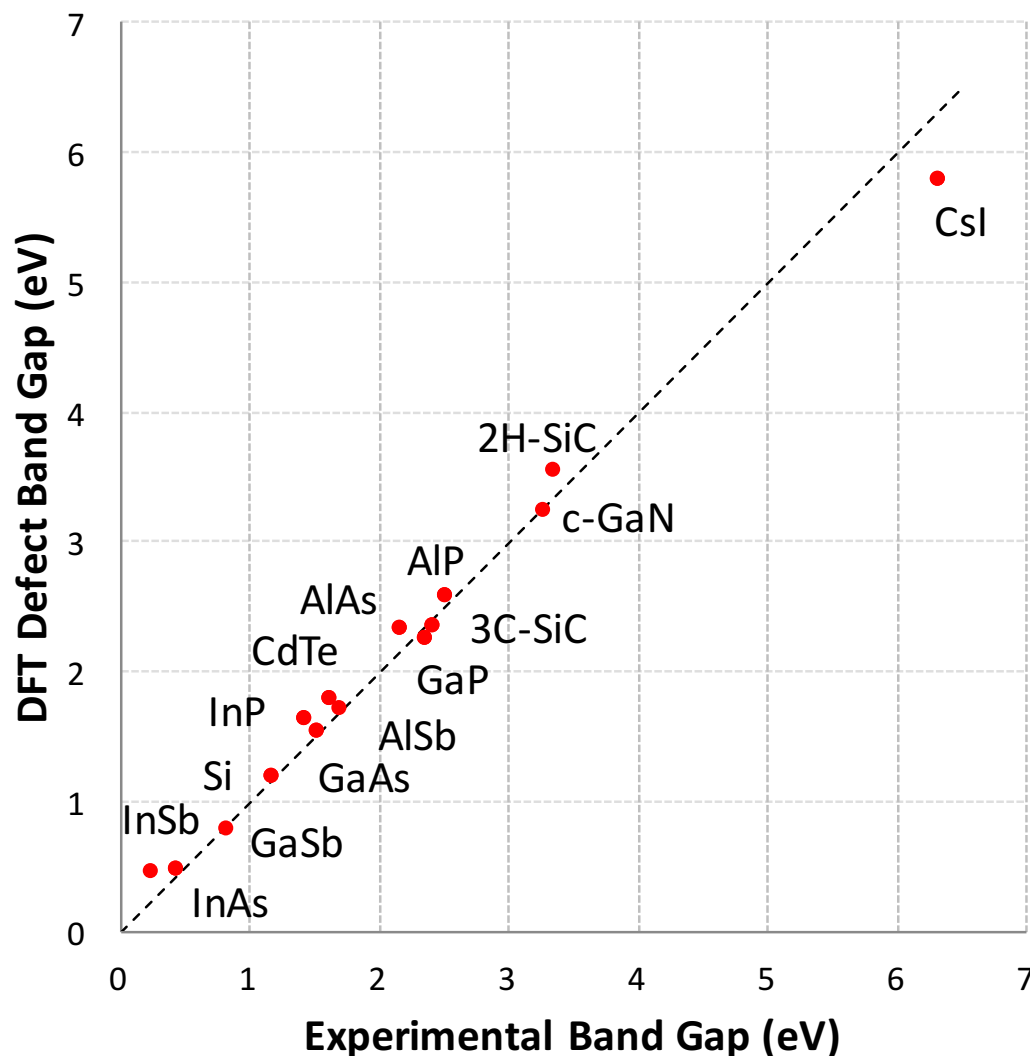
Too many defects!

Need **1000-site** supercells to discriminate localized defects

Need to resolve finite-size errors near band edges



The PBE Defect Gap vs. the Band Gap



PBE defect gap = experiment, *despite a band gap problem*

Conclusions

- “If you do not have the right band gap, you cannot hope to get the defect levels right” ?

- **Defect band gap** predicts experimental band gap, despite KS-DFT band gap error
 - Insensitive to change in functional (LDA vs. PBE), or pseudopotential
 - Varied KS-DFT gap (GaAs “laboratory”) → no change in levels or defect gap
 - Zero KS-DFT band gap (InSb, InAs, GaSb) → good defect band gap
 - Insensitive to k-sample gap (Si k-sample gap = KS gap)
 - **Semilocal DFT+FDSM** - quantitative (~ 0.1 eV) for defect levels (where HSE fails)
- importance of boundary conditions and finite size (supercell) effects

----- Supporting slides -----

CsI defect level spectrum - DFT

R. M. Van Ginhoven and P.A. Schultz, J.Phys.: Cond. Matter **25**, 495504 (2013)

250-site results = 432-,686-site

Verification: cell-converged

v_I levels match experiment

Validation of accuracy

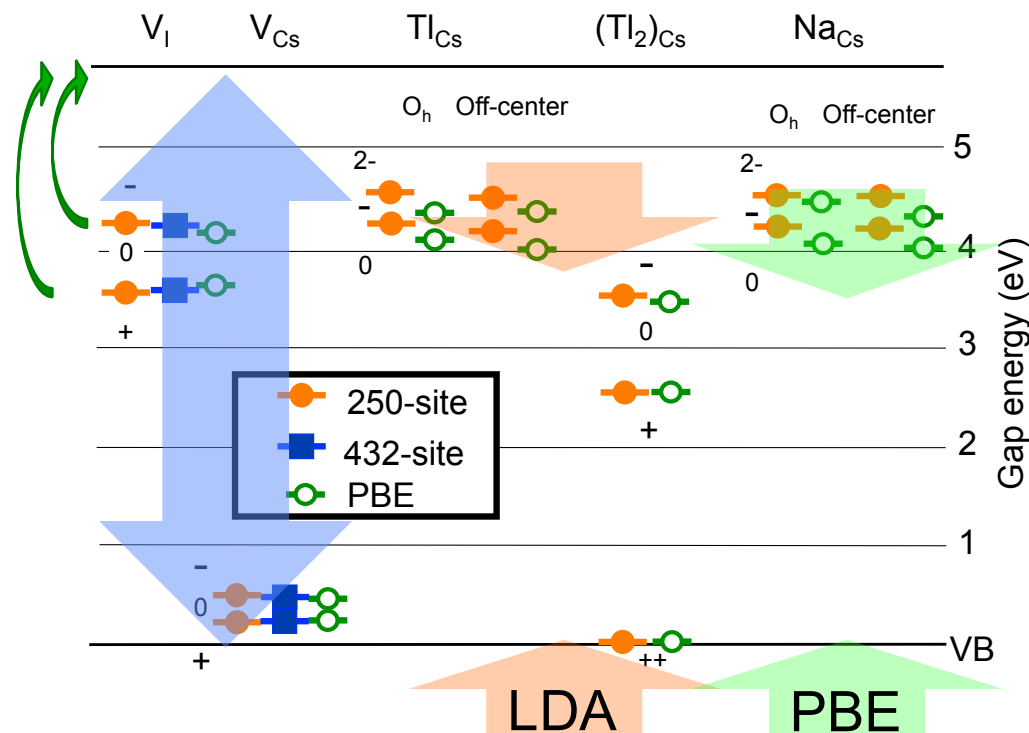
CsI band gap

KS-LDA: 3.80 eV

KS-PBE: 3.58

Defect span: >5.8 eV

Experiment: 6.3 eV

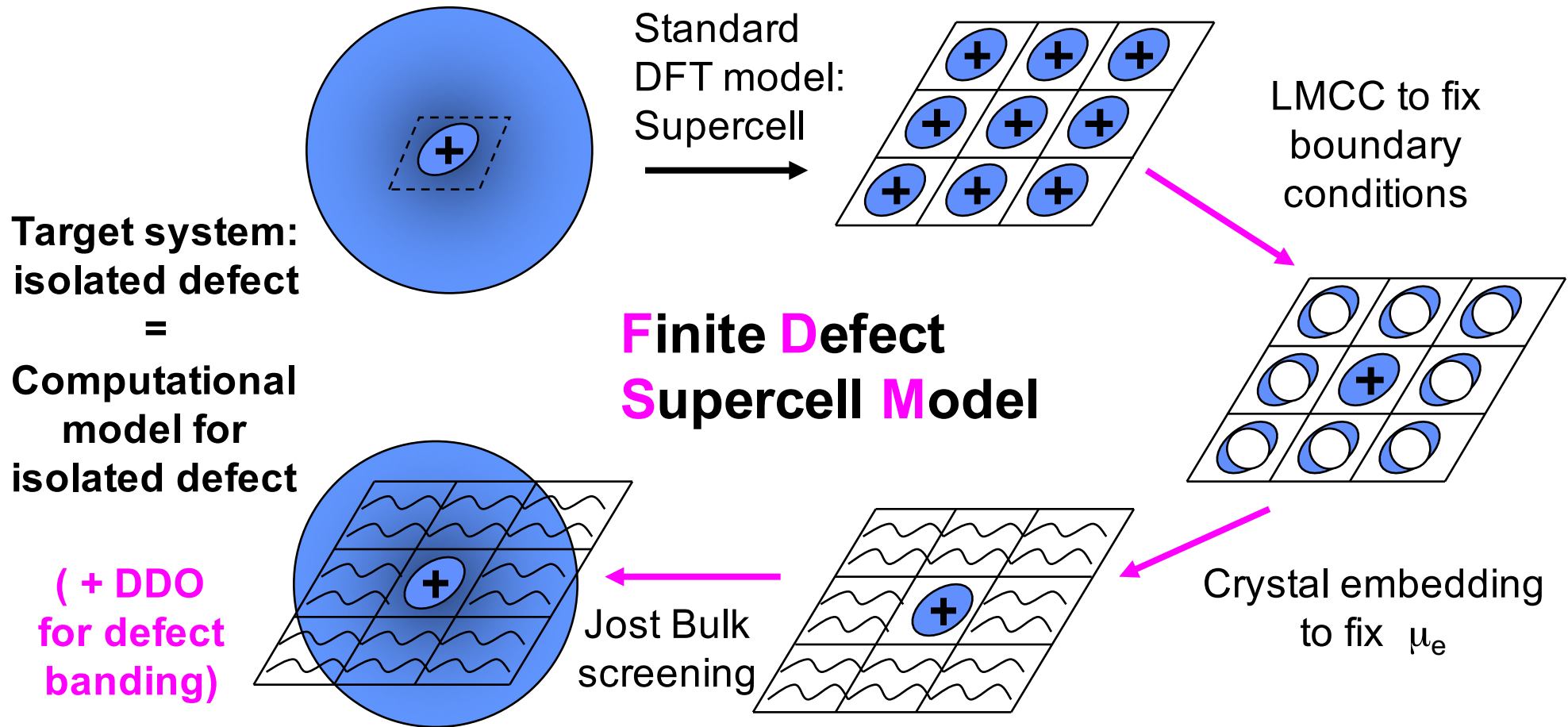


Not a band **gap** problem, a **band edge problem**—
where are they cf. total energy defect levels?

A supercell theory of defect energies

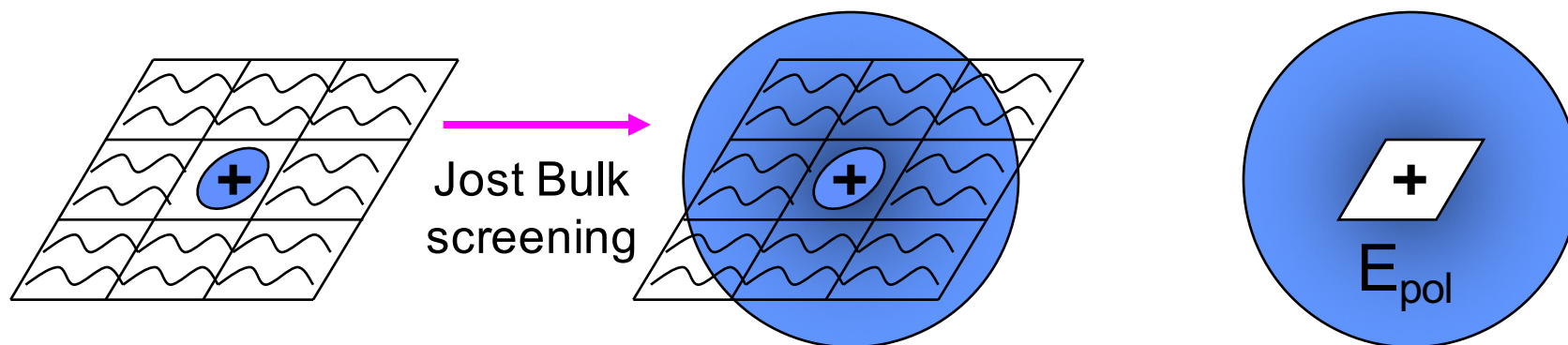
Peter A. Schultz, Phys. Rev. Lett. **96**, 246401 (2006).

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**FDSM: *Ab initio* computational model – connect model to physics
Calculations with rigorous control of charge boundary conditions**

The polarization model



For extrapolation to bulk, need energy of screening outside of supercell: E_{pol}

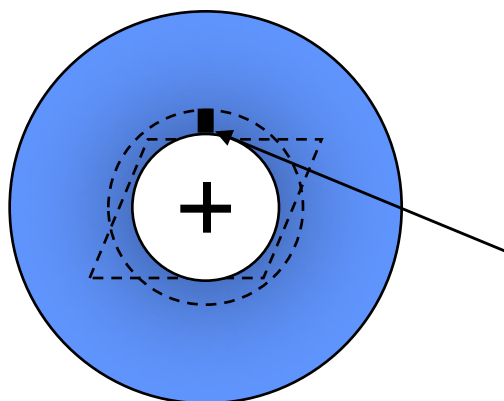
Jost model:
$$E_{pol} = \frac{(1 - 1/\epsilon_0) q^2}{R_{jost}}$$

$$R_{jost} = R_{vol} - R_{skin}$$

q = charge on defect

$$R_{jost} = R_{vol} - R_{skin}$$

R_{vol} = radius of volume sphere



Two parameters for any material

R_{skin} = unscreened
volume **inside** cell.
fit: =1.3-1.7 Bohr

ϵ_0 = static dielectric constant - expt

Si	GaAs	InP	GaP	AlAs	InAs
11.8	13	12.5	11.2	10.1	15.15